

10025899
12/26/2001

PATENT NUMBER and
ISSUE DATE

U.S. UTILITY Patent Application

APPL NUM 10025899	FILING DATE 12/26/2001	CLASS 427	SUBCLASS —	GAU 1762	EXAMINER P. 140
**APPLICANTS: Akizuki Makoto; Harada Mitsuaki; Ogasawara Satoru; Doi Atsumasa, Yamada Isao, Matsuo Jiro;					
**CONTINUING DATA VERIFIED: THIS APPLICATION IS A CON OF 09/799,681 03/07/2001 WHICH IS A CON OF 09/565,740 05/09/2000 ABN WHICH IS A CON OF 38/951,959 10/17/1997 ABN WHICH IS A CON OF 08/650,905 05/17/1996 ABN					
** FOREIGN APPLICATIONS VERIFIED: JAPAN 121983/1995 05/19/1995 JAPAN 244957/1995 09/22/1995 JAPAN 064861/1996 03/21/1996					
PG-PUB <input type="checkbox"/> DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>			
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials				ATTORNEY DOCKET NO 2001-1897	
TITLE : Method for forming gas cluster and method for forming thin film					

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Assistant Examiner	Total Claims Print Claim for O.G.
ISSUE FEE		Primary Examiner	DRAWING
Amount Due	Date Paid		Sheets Drwg. Figs.Drwg. Print Fig.
<input type="checkbox"/> TERMINAL DISCLAIMER		PREPARED FOR ISSUE	Application Examiner
		WARNING: The information disclosed herein may be restricted. Unauthorized disclosure may be prohibited by the United States Code Title 35, Sections 122, 181 and 368, Possession outside the U.S. Patent & Trademark Office is restricted to authorized employees and contractors only.	

FILED WITH:

☐ DISK (CRF)

☐ CD-ROM

(Attached in pocket on right inside flap)